

01-21-00

**PATENT**  
**MIC04 P-106**  
**Express Mail No. EL399135959US**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant : Imad Mahawili, PhD**  
**For : REACTOR WITH REMOTE PLASMA SYSTEM AND**  
**METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE**

**BOX PATENT APPLICATION**  
**Assistant Commissioner for Patents**  
**Washington, D.C. 20231**

**Dear Sir:**

Enclosed herewith is the above identified patent application comprising the following parts:

- 1) Postcard
- 2) Assignment, Form PTO-1619 Recordation Form Cover Sheet, and Assignment Recording Fee of \$40.00
- 3) 12 Pages of Specification
- 4) 6 Pages of Claims (54 claims)
- 5) 1 Page of Abstract
- 6) 5 Sheets of Drawings (in duplicate)
- 7) Declaration and Power of Attorney
- 8) Verified Statement Claiming Small Entity Status

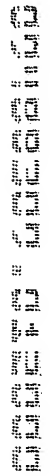
**Filing Fee:**

Basic Fee \$345.00 \$345.00

**Additional Fees**

Each independent claim in excess  
of three, times \$39.00 \$

Number of claims in excess of  
twenty, times \$9.00 \$306.00



Filing multiple dependent claims  
per application \$130.00 \$

Total Filing Fee \$651.00

Checks in the amount of \$651.00 and \$40.00 are enclosed to cover the fees noted above.

The Commissioner is hereby authorized to charge payment of the following fees associated with this communication, and during the pendency of this application, or to credit any overpayment, to Deposit Account No. 22-0190. A duplicate copy of this sheet is enclosed.

- 1) Any additional filing fees required under 37 CFR 1.16 for which full payment has not been tendered.
- 2) Any patent application processing fees under 37 CFR 1.17 for which full payment has not been tendered.

Respectfully submitted,

IMAD MAHAWILI PHD

By: Van Dyke, Gardner, Linn & Burkhart, LLP

January 19, 2000  
Date

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Box Patent Application  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF EXPRESS MAIL

I certify that the attached return postcard, Transmittal Letter (in duplicate),  
Form PTO-1619 Recordation Form Cover Sheet, Assignment, Assignment recordal fee of  
\$40.00 (check), Verified Statement Claiming Small Entity Status, 12 pages of Specification,  
6 pages of Claims (54 claims), 1 page of Abstract, 5 sheets of Drawings (in duplicate),  
Declaration and Power of Attorney, filing fee of \$651.00 (check) are being deposited with the  
United States Postal Service as Express Mail in an envelope having Express Mail Label  
Number EL399135959US addressed to:

Box Patent Application  
Assistant Commissioner for Patents  
Washington, D.C. 20231

on January 19, 2000.

Lynette M. S. Clark  
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Enclosures